## Search Notes



Applicant(s)/Patent under Reexamination

2814

10/823,298 REN, LIPING
Examiner Art Unit

Marcos D. Pizarro

SEARCHED					
Class	Subclass	Date	Examiner		
257	335-343 409 487,488 491-493 659	11/4/2008	/MP/		
		l			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
•	DATE	EXMR	